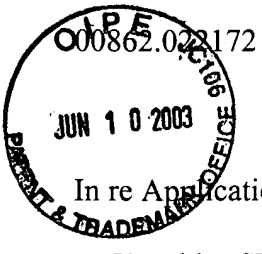


2881  
\$



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuhiro SHIMADA et al.

Application No.: 09/819,669

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,  
METHOD OF FABRICATING THE SAME,  
CHARGED PARTICLE BEAM EXPOSURE  
APPARATUS, AND DEVICE  
MANUFACTURING METHOD

)  
:  
) Examiner: K. Nguyen  
:  
) Group Art Unit: 2881  
:  
)  
:  
)  
:  
) June 10, 2003  
:  
)  
:  
)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☐ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	23	MINUS	25	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	8	MINUS	6	= 2	x \$42 \$84	\$168.00
Fee for Multiple Dependent claims \$140/\$280						—
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$168.00

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

RECEIVED  
JUN 12 2003  
TECHNOLOGY CENTER 2800



A check in the amount of \$ 168.00 is enclosed including the additional claims fee.



Charge \$\_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.



Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.



A check in the amount of \$\_\_\_\_\_ to cover the fee for a two month extension is enclosed.



A check in the amount of \$\_\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.



Applicants' attorney, Scott D. Malpede, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Jack S. Cubert

Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

DC\_MAIN 135061 v 1



00862.022172

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: K. Nguyen
Yasuhiro SHIMADA et al.	)	
	:	Group Art Unit: 2881
Application No.: 09/819,669	)	
	:	
Filed: March 29, 2001	)	
	:	
For: ELECTRON OPTICAL SYSTEM ARRAY,	)	
METHOD OF FABRICATING THE SAME,	:	
CHARGED PARTICLE BEAM EXPOSURE	)	
APPARATUS, AND DEVICE	:	
MANUFACTURING METHOD	)	June 10, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated March 10, 2003, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."

06/11/2003 NMOHAMM1 00000052 09819669

01 FC:1201

168.00 0P

RECEIVED  
JUN 12 2003  
TECHNOLOGY CENTER 2800